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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2826
 Examiner: Feifei Yeung Lopez

In Re PATENT APPLICATION Of:

Applicant(s): Mineo MIURA)
 Serial No.: 10/588,103)
 Filed: July 31, 2006) **AMENDMENT AF**
 For: SEMICONDUCTOR DEVICE AND)
 METHOD FOR MANUFACTURING)
 THE SAME)
 Docket No.: AI 420NP)
)
 December 29, 2008

Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on September 29, 2008, please
 amend the above-identified application as follows:

FREE ENCLOSED: \$ 0
 Please charge any further fee to
 our Deposit Account No. 18-0002